INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

May 12, 2026

IGI Report Number	LG800664986
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	10.86 X 7.51 X 5.18 MM

GRADING RESULTS

Carat Weight	4.09 CARATS
Color Grade	F
Clarity Grade	VS 1

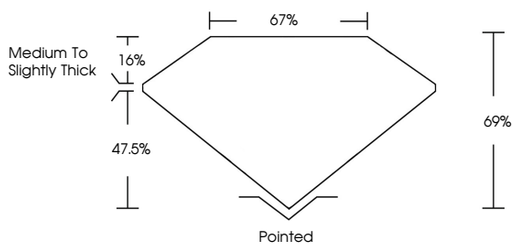
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG800664986

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800664986
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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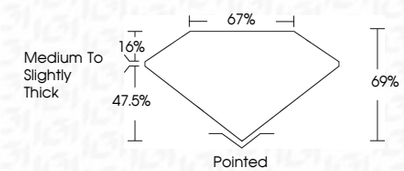

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IGI

May 12, 2026
IGI Report No LG800664986
CUT CORNERED RECT. MODIFIED BRILLIANT
10.86 X 7.51 X 5.18 MM
Carat Weight 4.09 CARATS
Color Grade F
Clarity Grade VS 1
Depth 69%
Table 67%
Girdle Medium To Slightly Thick
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG800664986
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa